

OCT 12 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hopper, Peter

Attorney Docket No.: NSC1P282/P05730

Application No.: 10/665,897

Examiner: Rose, Kiesha

Filed: Sept. 18, 2003

Group: 2822

Title: APPARATUS AND METHOD FOR
FORMING HEAT SINKS ON SILICON ON
INSULATOR WAFERS

Confirmation No. 6996

CERTIFICATE OF FACSIMILE TRANSMISSIONI hereby certify that this correspondence is being transmitted by
facsimile to fax number 571-273-8300 to the U.S. Patent and
Trademark Office on October 12, 2005.Signed: 

Agnes Spencer

AMENDMENT CMail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Advisory Action dated August 24, 2005, please amend the
above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin
on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.